



501.42174VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: R. FURUKAWA, et al.
Application No.: 10/699,690
Filed: November 4, 2003
For: METHOD FOR MANUFACTURING SEMICONDUCTOR
INTEGRATED CIRCUIT DEVICE
Art Unit: 2818
Examiner: Q. Hoang

INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §§ 1.97 AND 1.98

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 15, 2004

Sir:

Pursuant to Applicants' duty of disclosure, and as a supplement to the Information Disclosure Statement dated October 18, 2004, enclosed please find English translations of Japanese Patent Document No. 2001-284463 and No. 2001-298095, submitted with the Information Disclosure Statement dated October 18, 2004. Note that an English abstract and specified figures of the above-identified Japanese patent documents were submitted with the Information Disclosure Statement submitted October 18, 2004.

Please note that in the enclosed English translation of No. 2001-298095, the expression of "6: silicon oxide film containing nitrogen" in Fig. 2 of the materials submitted on October 18, 2004 has been corrected to that of "6: silicon oxide film including nitrogen".

Also enclosed herewith is a replacement Form PTO/SB/08A, for the Form PTO/SB/08A filed with the Information Disclosure Statement dated October 18, 2004, and reflecting the present filing of the respective English translations.

This Information Disclosure Statement is being submitted subsequent to the filing of a Request for Continued Examination (RCE) Transmittal in the above-identified

application, but prior to issuance of a further Office Action after submission of such RCE Transmittal. Accordingly, it is respectfully submitted that requirements of 37 CFR § 1.97(b) are satisfied, with respect to the present submission of the enclosed English translations.

In view of the foregoing, it is respectfully submitted that all applicable requirements of 37 CFR §§ 1.97 and 1.98 have been satisfied, in connection with documents submitted with the respective Information Disclosure Statements submitted on October 18, 2004 and on even date. Accordingly, consideration of the documents submitted with these Information Disclosures Statements, upon further examination of the above-identified application, is respectfully requested.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to the Antonelli, Terry, Stout & Kraus, LLP, Deposit Account No. 01-2135 (Docket No. 501.42174VX1), and please credit any excess fees to such deposit account.

Respectfully submitted,

ANTONELLI, TERRY, STOUT & KRAUS, LLP

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<p>Substitute for form 1449A/PTO</p> <p>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</p> <p><i>(use as many sheets as necessary)</i></p>		Complete if Known	
		Application Number	10/699,690
		Filing Date	November 4, 2003
		First Named Inventor	R. FURUKAWA, et al.
		Art Unit	2818
		Examiner Name	Q. Hoang
Sheet	1	of	1
		Attorney Docket Number	
		501.42174VX1	

U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS					
Examiner Initials ¹	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ –Number ⁴ –Kind Code <i>(if known)</i>			
		JP 2001-284463	10-12-2001	NEC	Trans & Abst
		JP 2001-298095	10-26-2001	NEC	Trans & Abst

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS

OTHER PRIOR ART—NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²

Examiner Signature		Date Considered	
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¹Applicant's unique citation designation number (optional). ²See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to place a check mark here if English language Translation is attached.

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